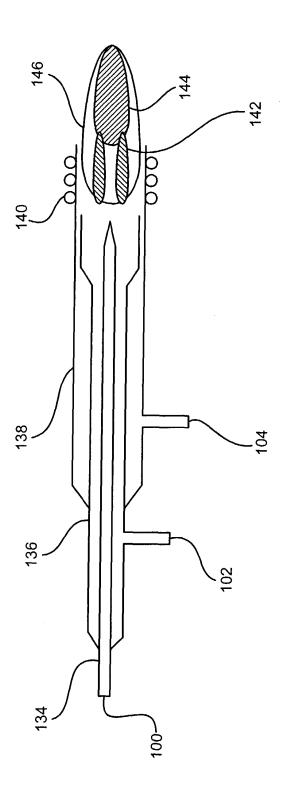
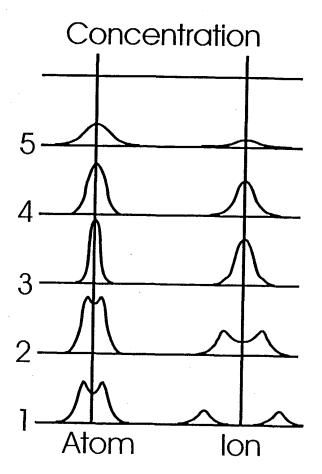
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Title: APPARATUS AND METHOD FOR REACTIVE ATOM PLASMA PROCESSING
FOR MATERIAL DEPOSITION
Inventors: Jeffrey W. Carr
Application No.: Unassigned
Docket No.: CARR-01000US4
Attorney: Jason D. Lohr
Telephone No. (415) 362-3800 -134 122--138 128-114, 

Figure 1



Inventors: Jeffrey W. Carr Application No.: Unassigned Docket No.: CARR-01000US4 Attorney: Jason D. Lohr

Filing Date: Herewith Art Unit: Unassigned Telephone No. (415) 362-3800



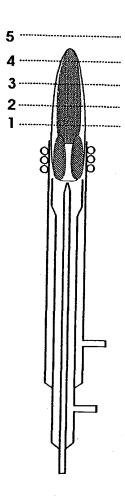


Figure 3

Inventors: Jeffrey W. Carr Application No.: Unassigned Docket No.: CARR-01000US4 Attorney: Jason D. Lohr

Filing Date: Herewith Art Unit: Unassigned Telephone No. (415) 362-3800

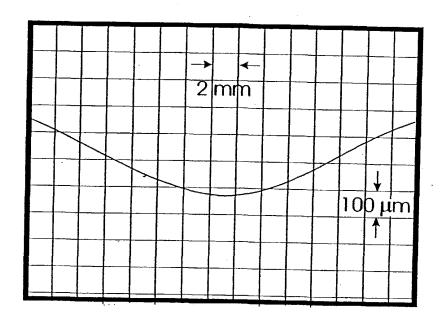


Figure 4

Inventors: Jeffrey W. Carr Application No.: Unassigned Docket No.: CARR-01000US4 Attorney: Jason D. Lohr

Filing Date: Herewith Art Unit: Unassigned Telephone No. (415) 362-3800

Place a workpiece in a plasma processing chamber including a plasma torch

500

Translate and/or rotate at least one of the the workpiece and the plasma torch with respect to each other

502

Use reactive atom plasma processing to shape the surface of the workpiece with the discharge from the plasma torch

<u>504</u>

Figure 5

Inventors: Jeffrey W. Carr Application No.: Unassigned Docket No.: CARR-01000US4 Attorney: Jason D. Lohr

Filing Date: Herewith Art Unit: Unassigned Telephone No. (415) 362-3800

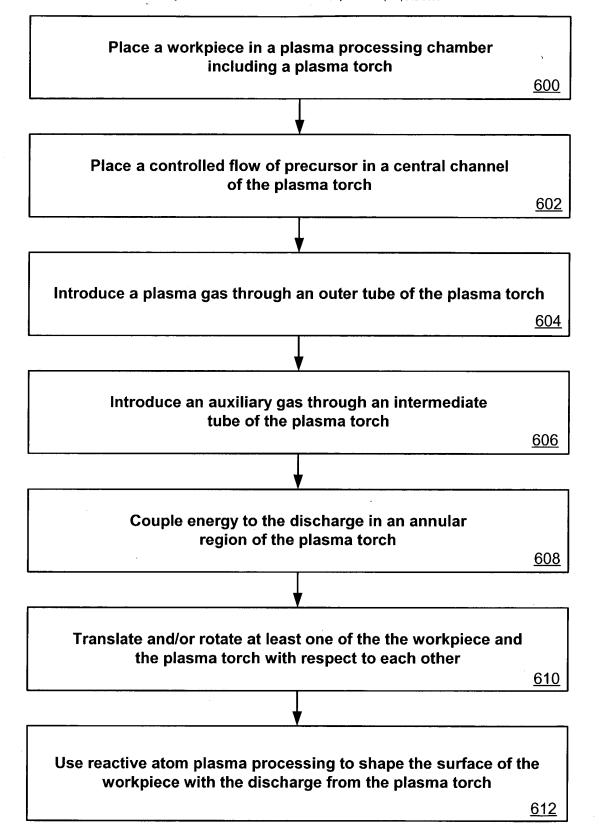


Figure 6